

Notice of References Cited	Application/Control No. 10/590,835		Applicant(s)/Patent Under Reexamination OGAWA ET AL.	
	Examiner Peter Y. Choi		Art Unit 1794	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2004/0100125	05-2004	Ogawa et al.	296/193.07
*	B	US-6,362,269	03-2002	Ishihata et al.	524/449
*	C	US-6,384,128	05-2002	Wadahara et al.	524/496
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	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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